



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukie NAKANO et al.

Application No.: 09/865,575

Group Art Unit: 2831

Filed: May 29, 2001

Examiner: Eric W. Thomas

For: MULTILAYER CERAMIC CAPACITOR AND PRODUCTION METHOD THEREOF

Docket No.: 109639

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

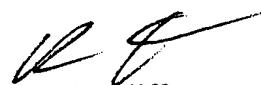
Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination and entry and consideration of the December 2, 2002 Amendment After Final Rejection submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 138514 in the amount of  \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Director is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

Richard J. Kim  
Registration No. 48,360

JAO:RJK/mdw

Date: January 29, 2003

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461

750.00 op

01/30/2003 WADDER1 00000037 09865575

01 FC:1801

RECEIVED  
TECHNOLOGY CENTER 2600  
FEB -3 2003

#14/RCCE  
RECEIVED  
FEB -3 2003